



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Farnworth et al.

Serial No.: 09/589,841

Filed: June 8, 2000

For: STEREOLITHOGRAPHIC
METHODS FOR FORMING A
PROTECTIVE LAYER ON A
SEMICONDUCTOR DEVICE SUBSTRATE
AND SUBSTRATES INCLUDING
PROTECTIVE LAYERS SO FORMED

Confirmation No.: 1415

Examiner: G. Lee

Group Art Unit: 2825

Attorney Docket No.: 3923US (99-0033)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

March 4, 2003
Date

Signature

Deidra J. Pfeil
Name (Type/Print)

16/Response
3-12-03
Aweel

RESPONSE

Box Non Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

Sir:

This communication is in response to the Office Action mailed on December 4, 2002, the three-month shortened statutory period for response to which expires on March 4, 2003.